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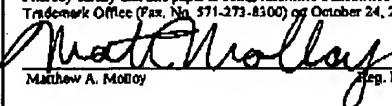
OCT 24 2005

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## Application of

Applicants : Zheng et al.  
Serial No. : 10/790,492  
Filed : March 1, 2004  
Title: : **Atomic Layer Deposition of Capacitor Dielectric**  
Docket No. : MIO 0082 N2/40509.292  
Examiner : Thomas, Toniae M  
Art Unit : 2822  
Conf. No. : 9512

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION	
I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office (Fax. No. 571-273-8300) on October 24, 2005.	
 Matthew A. Molloy Reg. No. 56,415	

Sir or Madam:

AMENDMENT

This paper is being filed in response to the Office Action mailed July 22, 2005. Reconsideration of the present application is respectfully requested in light of the amendments and remarks below, which include, in order of appearance, beginning on separate sheets:

- Amendments to the Claims; and
- Remarks.